



S/N 10/634,174

**PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Leonard Forbes

Examiner: Joannie A. Garcia

Serial No.: 10/634,174

Group Art Unit: 2823

Filed: August 5, 2003

Docket: 1303.102US1

Title: STRAINED SI/SIGE/SOI ISLANDS AND PROCESSES OF MAKING SAME

**COMMUNICATION CONCERNING RELATED APPLICATION(S)**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicant would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date/Issue Date</u>	<u>Attorney Docket</u>	<u>Title</u>
10/979994	November 3, 2004	1303.102US2	STRAINED Si/SiGe/SOI ISLANDS AND PROCESSES OF MAKING SAME
	June 27, 2005	1303.108US3	GETTERING USING VOIDS FORMED BY SURFACE TRANSFORMATION

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

LEONARD FORBES

By Applicant's Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 373-6960

Date 7-13-05By Marvin L. Beekman  
Reg. No. 38,377

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 14 day of July, 2005.

Name KACIA LEESignature Kacia Lee